

# Upright Metallurgical Microscope NM910/NM930





http://www.nexcope.com

# **Excellent NIS Optical System**

With excellent NIS optical system, NM900 series microscope provides high resolution and chromatic aberration corrected images both in the eyepieces and on the monitor.



# Modular Design

NM900 series has been designed with modularity to meet vairous industrial and materials science applications. It gives users flexibility to build a system for specific needs.



NM910

NM930

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# Intuitive Microscope Controls

## **Remote Control Pad**

Objectives could be switched by simply pressing the rotating buttons. Users could also self-define two of the most commonly used objectives. User could swap between these two objectives by pressing the green button.



#### **Shortcut Buttons**

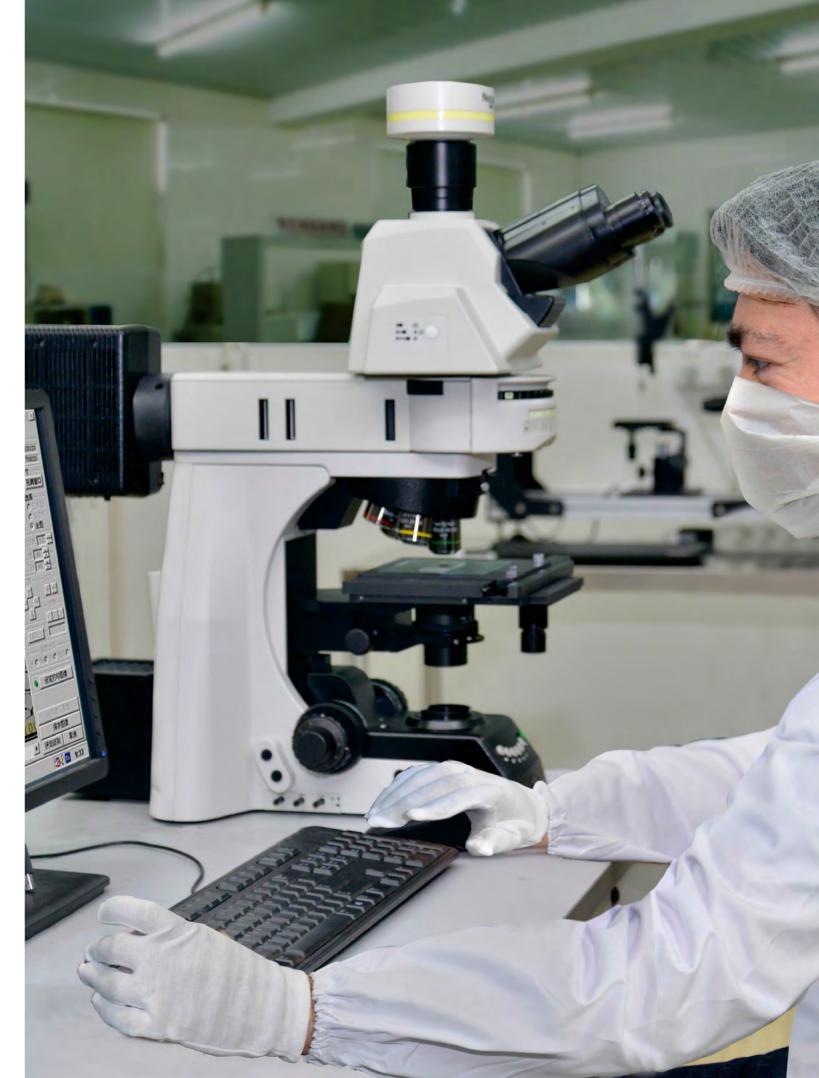
With this shortcut button, the user could switch 2 preseted objectives fast. Also, this shortcut button could be set with other functions by user.



## **ECO Function**

The microscope light would be off automatically after 30 minutes from operators leave. It can not only save energy, but also save the lamp lifetime.





# Intuitive Microscope Controls

# **NIS45 Series Objectives**

By using carefully selected high-transparent glass and advanced coating technology, NIS45 objective lens can provide high resolution image and accurately reproduce the natural color of the specimen . For special applications, a variety of objectives is available, including polarizing and long working distance.



#### Nomarski DIC

With newly designed DIC module, the height difference of a specimen which can not be detected with brightfield becomes a relief-like or 3D image. It is ideal for the observation of LCD conducting particles and the surface scratches of hard-disk etc.



## **Ergo Tilting Trinocular Head**

Eye tube can be adjustable from 0 ° to 35°, Trinocular tube can be connected to SLR camera and digital camera, having a 3-postion beam splitter (0:100, 100:0, 80:20), the splitter bar can be assembled on the either side according to user's requirement.



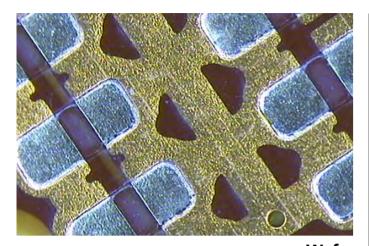
## **Focusing system**

In order to make the system suitable for the operating habits of the operators, the knob of focusing and stage can be adjusted to the left-hand side or righthand side. This design makes the operation comfortable.





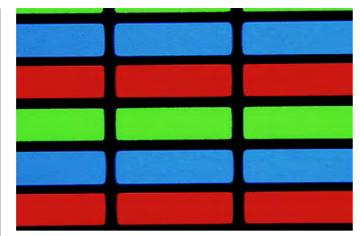
# **Various Observation Methods**





#### **Darkfield**

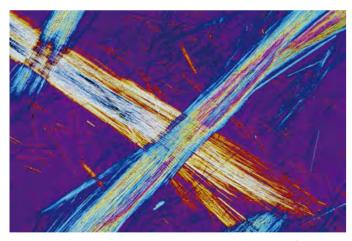
Darkfield enables the observation of scattered or diffracted light from the specimen. Anything that is not flat reflects this light while anything that is flat appears dark so imperfections clearly stand out. The user can identify the existence of even a minute scratch or flaw down to the 8nm level-smaller than the resolving power limit of an optical microscope. Darkfield is ideal for detecting minute scratches or flaws on a specimen and examining mirror surface specimens, including wafers.



**LCD** 

#### **Transmitted Light Observation**

For transparent specimen such as LCDs, plastics, and glass materials, true transmitted light observation is available by using a variety of condensers. Examining specimen in transmitted brightfield and polarized light can be accomplished all in one convenient system.



**Asbestos** 

## **Polarized Light**

This microscopic observation technique utilizes polarized light generated by a set of filters (analyzer and polarizer). The characteristics of the sample directly affect the intensity of the light reflected through the system. It is suitable for metallurgical structures (i.e., growth pattern of graphite on nodular casting iron), minerals, LCDs and, semiconductor materials.



**Conducting Particles** 

#### **Differential Interference Contrast**

DIC is a microscopic observation technique in which the height difference of a specimen not detectable with brightfield becomes a relief-like or three- dimensional image with improved contrast. This technique utilizes polarized light and can be customized with a choice of three specially designed prisms. It is ideal for examining specimens with very minute height differences, including metallurgical structures, minerals, magnetic heads, hard-disk media, and polished wafer surfaces.

| NM910-R/TR     |  |  |  |
|----------------|--|--|--|
|                | NM910-R  | NM910-TR   |  |
| Optical System | NIS45 Infinite optical system  |  |  |
| Eyepiece       | SW10X/25 SW10X/22 EW12.5X/16 WF15X/16 WF20X/12   |  |  |
| Viewing Head   | Ergo tilting trinocular head, adjustable from 0° to 35°, interpupilary distance 47-78mm<br>Seidentopf trinocular head, inclined at 30°, interpupilary distance 47-78mm<br>Seidentopf binocular head, inclined at 30°, interpupilary distance 47-78mm |  |  |
| Objective      | NIS45 Series objective   |  |  |
| Nosepiece      | Sextuplet nosepiece  |  |  |
| Condenser      | NA0.65   |  |  |
| Illumination   | Reflected light 24v/100w halogen lamp, kohler<br>illumination  | Reflected light 24v/100w halogen lamp, kohler<br>illumination<br>Transmitted light 24v/100w halogen lamp, kohler<br>illumination, with ND6/ND25 filter |  |
| Focusing       | Coaxial coarse and fine adjustment, fine division 1 um,<br>moving range 35mm, sample space 76mm  | Coaxial coarse and fine adjustment, Fine Division 1 um,<br>moving range 35mm,sample space 56mm   |  |
| Stage          | "4" ' Stage (right or left handle)<br>Double layer mechanical stage 190X / 152 / 78mmx32m (right or left handle)<br>Double layer mechanical stage 190X / 152 / 78mmx54mm (right or left handle)  |  |  |
| Accessories    | Power cord   |  |  |

| NM930-R/TR     |   |  |  |
|----------------|---|--|--|
|                | NM930-R   | NM930-TR   |  |
| Optical System | NIS45 Infinite optical system   |  |  |
| Eyepiece       | SW10X/25 SW10X/22 EW12.5X/16 WF15X/16 WF20X/12  |  |  |
| Viewing Head   | Ergo tilting trinocular head,adjustable from 0° to 35°, interpupilary distance 47-78mm<br>Seidentopf trinocular head,Inclined at 30°, interpupilary distance 47-78mm<br>Seidentopf binocular head,Inclined at 30°, interpupilary distance 47-78mm |  |  |
| Video Adapter  | 0.5 X C-Mount   |  |  |
| Objective      | NIS45 Series objective  |  |  |
| Nosepiece      | Auto sextuplet nosepiece  |  |  |
| Condenser      | NA0.65  |  |  |
| Illumination   | Reflected light 12v/100w halogen lamp, kohler illumination  | Reflected light 12v/100w halogen lamp, kohler<br>illumination<br>Transmitted light 12v/100w halogen lamp, kohler<br>illumination, with ND6/ND25 filter |  |
| Focusing       | Coaxial coarse and fine adjustment, fine division 1 um, moving range 35mm, sample space 76mm  | Coaxial coarse and fine adjustment, fine division 1 um,<br>moving range 35mm, sample space 56mm  |  |
| Stage          | "4" ' Stage (right or left handle) Double layer mechanical stage 190X / 152 / 78mmx32m (right or left handle) Double layer mechanical stage 190X / 152 / 78mmx54mm (right or left handle)   |  |  |
| Accessories    | Neximage 10.0   |  |  |
|                | Power cord  |  |  |

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PT6B-L/R

PT6B-L/R

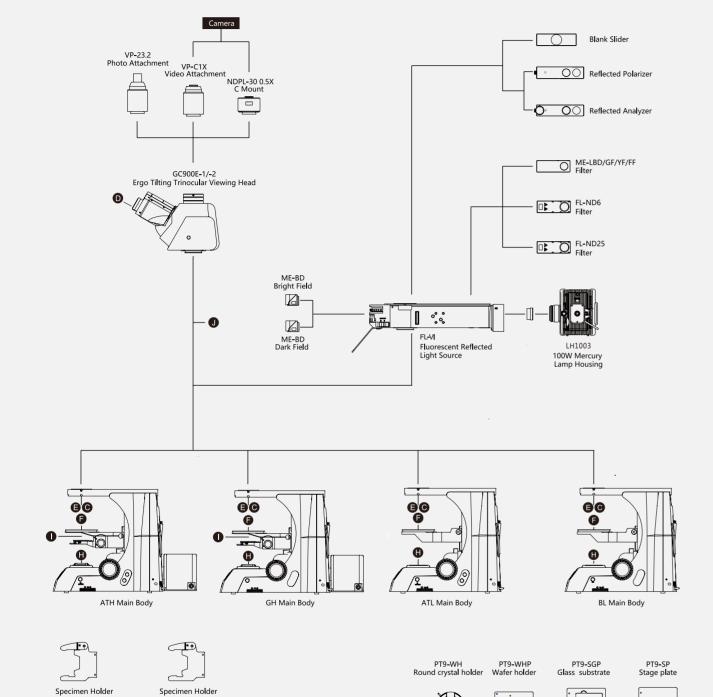
Stage with Gorilla Glass Insert Stage with Sapphire Crystal Glass Insert

PT9-L/R

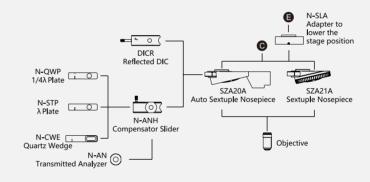
Unit:mm

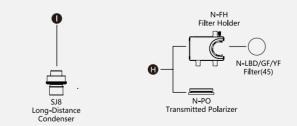
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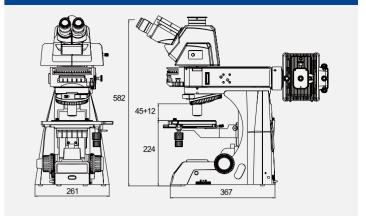
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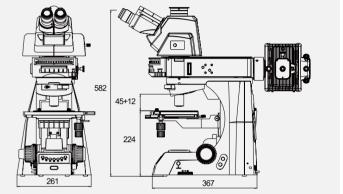




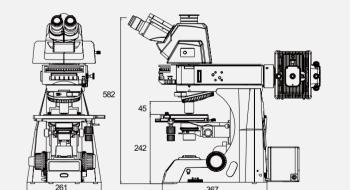








#### NM910-TR Dimension



#### NM930-TR Dimension

